

# Innovative relaxed InGaN engineered substrates for RGB Micro-LEDs

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- Efficient blue and green LEDs are in Nitride, red LEDs are in Phosphide
- Phosphide red LEDs are intrinsically not efficient at micrometer-scale ( $\leq 10 \mu\text{m}$ )
- Nitride red microLEDs are the ideal solution
- but efficiency is limited by strain between substrate and the InGaN structure
- → need relaxed InGaN engineered substrate for strain management

- 1- InGaNOS: the relaxed InGaN engineered substrate
- 2- First red microLEDs
- 3- Conclusion and perspectives

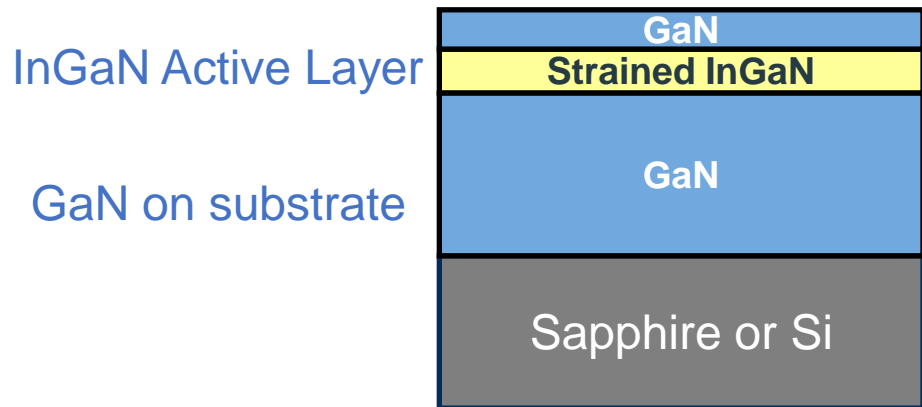
## PART 1

# InGaNOS: the relaxed InGaN engineered substrate

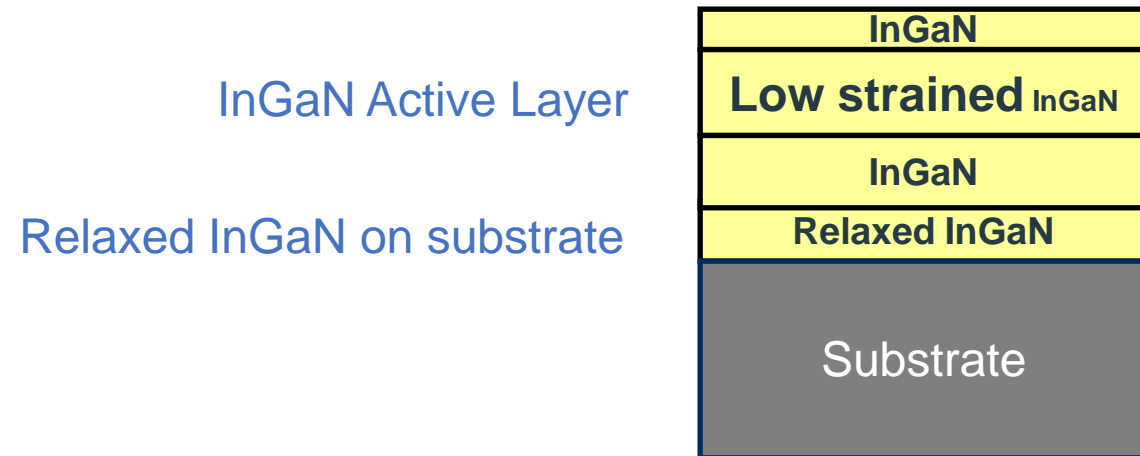
# Nitride red LEDs non availability is caused by thermodynamic & strain limitations

- Soitec targets to reduce strain between InGaN (Active Layer) and GaN

**Current technology**  
**Strain between Active Layer & GaN**

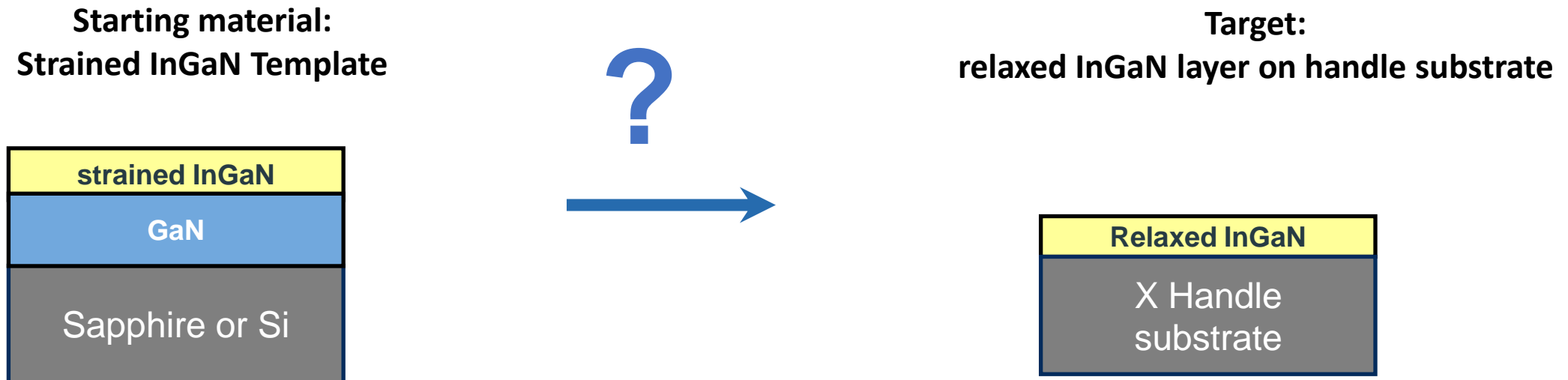


**Ideal low strain structure:**  
**Full InGaN structure**



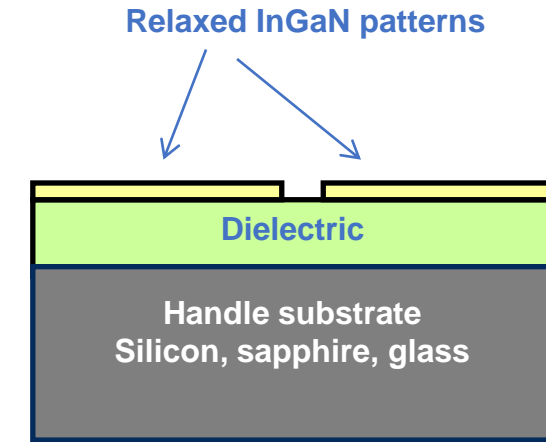
- How to fabricate full InGaN structure ?

- Starting material: strained InGaN Template
- Targeted substrate: relaxed InGaN layer on handle substrate

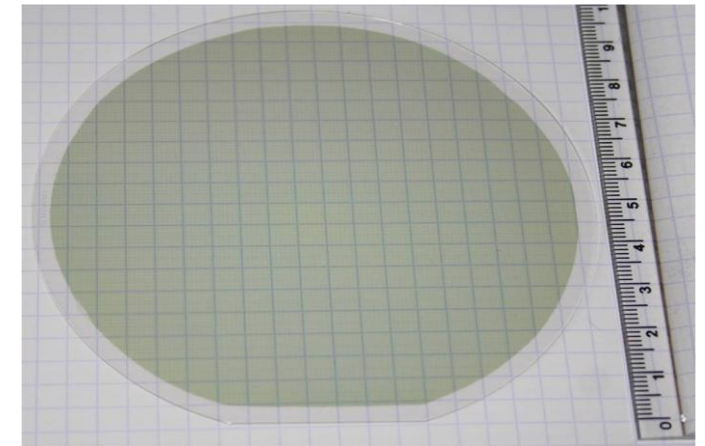


- How to fabricate substrate with relaxed InGaN layer?

- Top relaxed InGaN layer
  - Ga-face epi-ready substrate
  - Monocrystalline InGaN layer, C plane orientation
  - Pattern size: from 1x1 mm<sup>2</sup> down to 5x5 μm<sup>2</sup>
  - Lattice parameter: from 3,200 to 3,214 Å
- Dielectric layer compatible with GaN growth
- Handle substrate agnostic (Sapphire, Silicon, glass)
- Development and microLED growths are done on InGaN-on-Sapphire (InGaNOS)

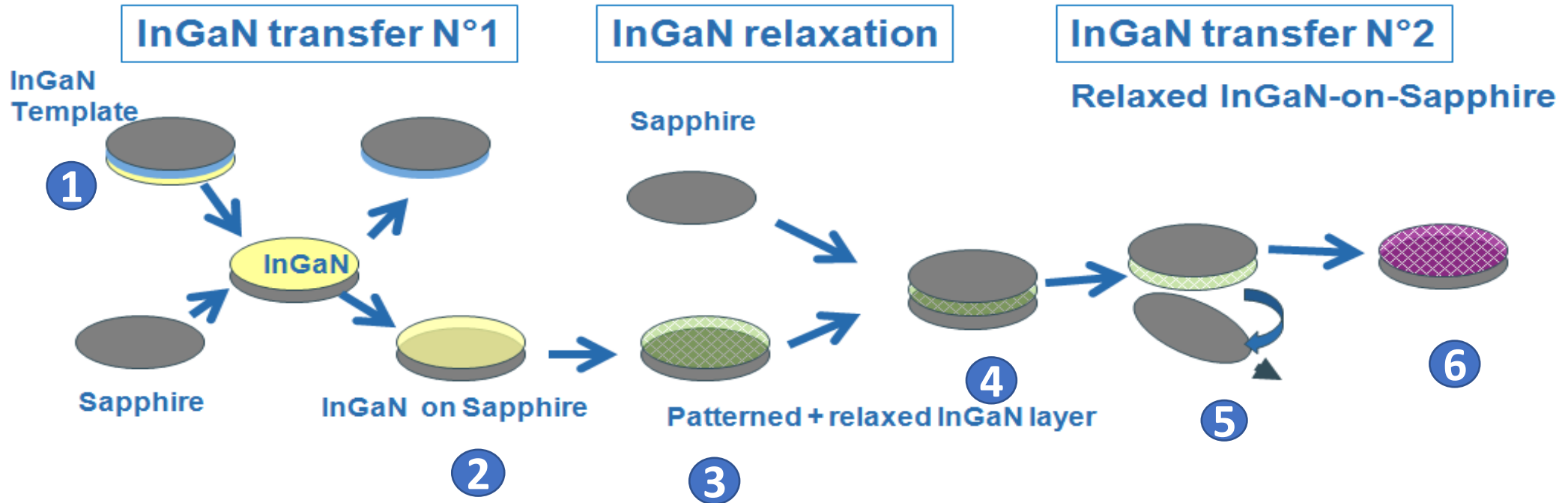


Structure of InGaN-on-X







100mm InGaN-on-sapphire

# InGaNOS substrate fabrication process

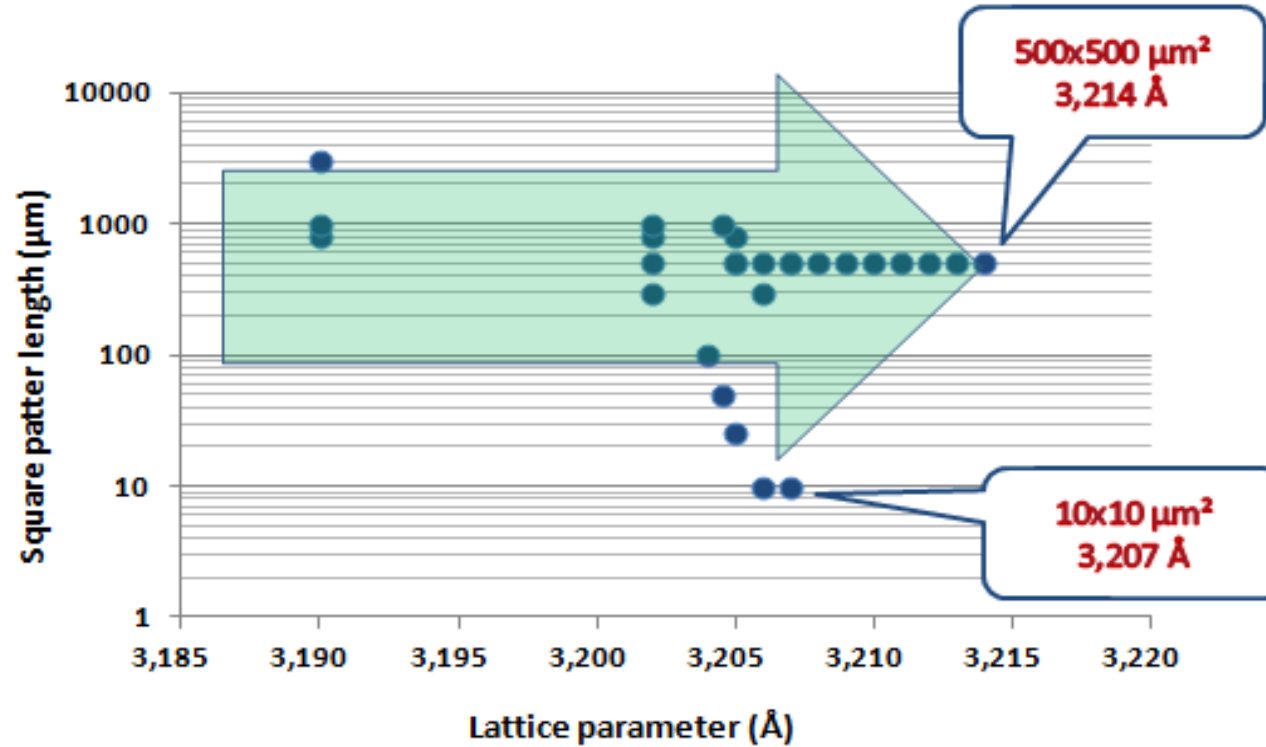
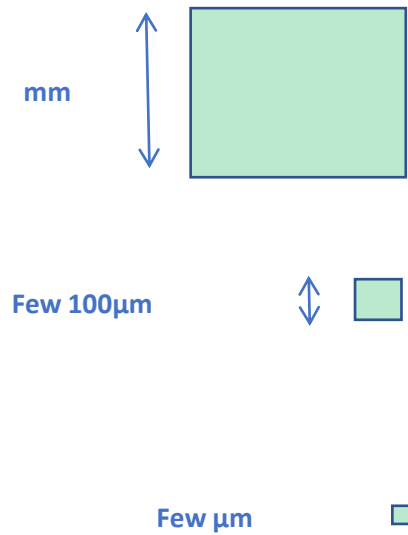


> Legend:

-  Sapphire
-  GaN
-  Strained InGaN (Ga face)
-  Relaxed InGaN (Ga face)
-  Relaxed InGaN (N face)



# Towards high lattice parameters: 3,214 Å for 500x500 $\mu\text{m}^2$ patterns



- InGaNOS substrates equivalent up to 7% fully relaxed InGaN Templates

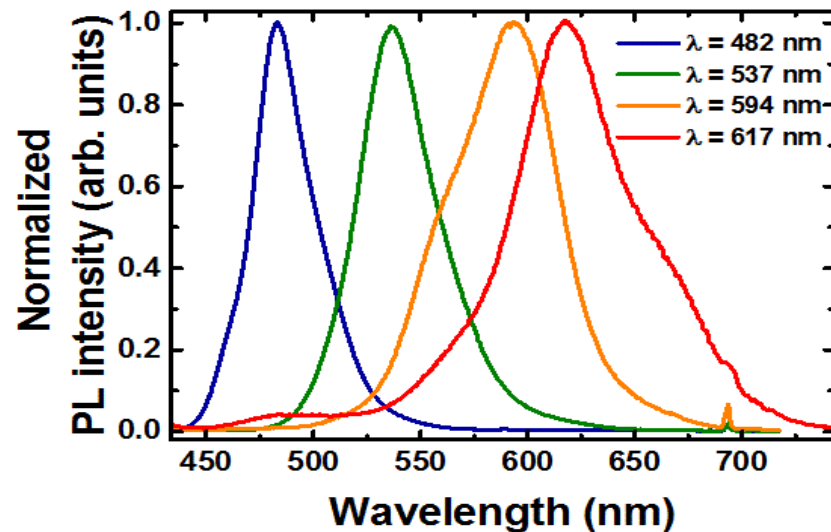
- **What we need to demonstrate:**
- Indium incorporation dependence with lattice parameter
- More than 25% Indium incorporation in Quantum Wells
- Demonstration of first full InGaN red microLEDs

## PART 2

### First red microLEDs



- Co-loaded InGaNOS substrates with different lattice parameters.
- Same epi growth conditions for n-doped InGaN buffer and InGaN/ InGaN Quantum Wells
- Emission wavelength tuning from blue to red

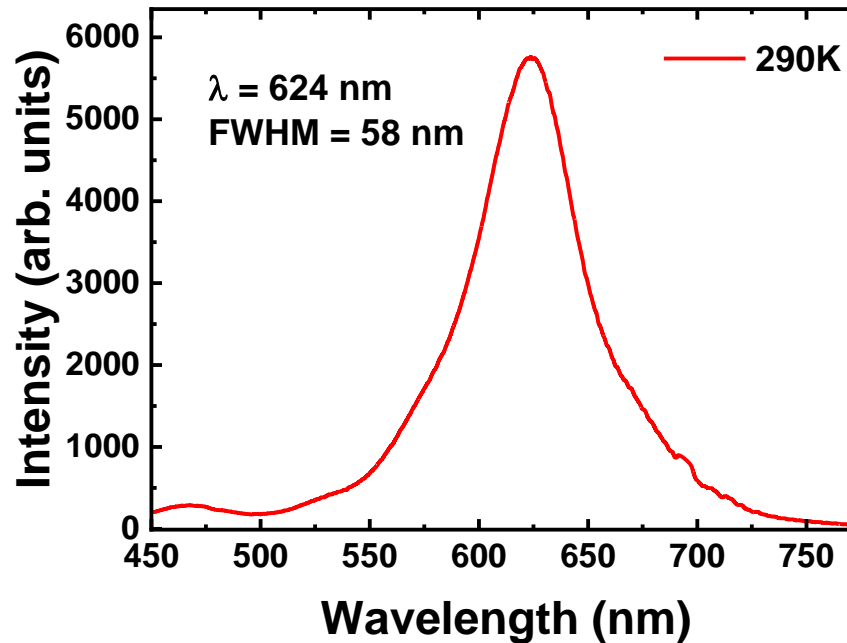


InGaNOS Lattice parameter	$\lambda$ peak	FWMH
3.190 Å	482nm	33nm
3.200 Å	537nm	41nm
3.205 Å	594nm	60nm
3.205 Å	617nm	63nm

- Indium incorporation dependence with lattice parameter ✓

# 6.5% red Internal quantum efficiency (IQE)

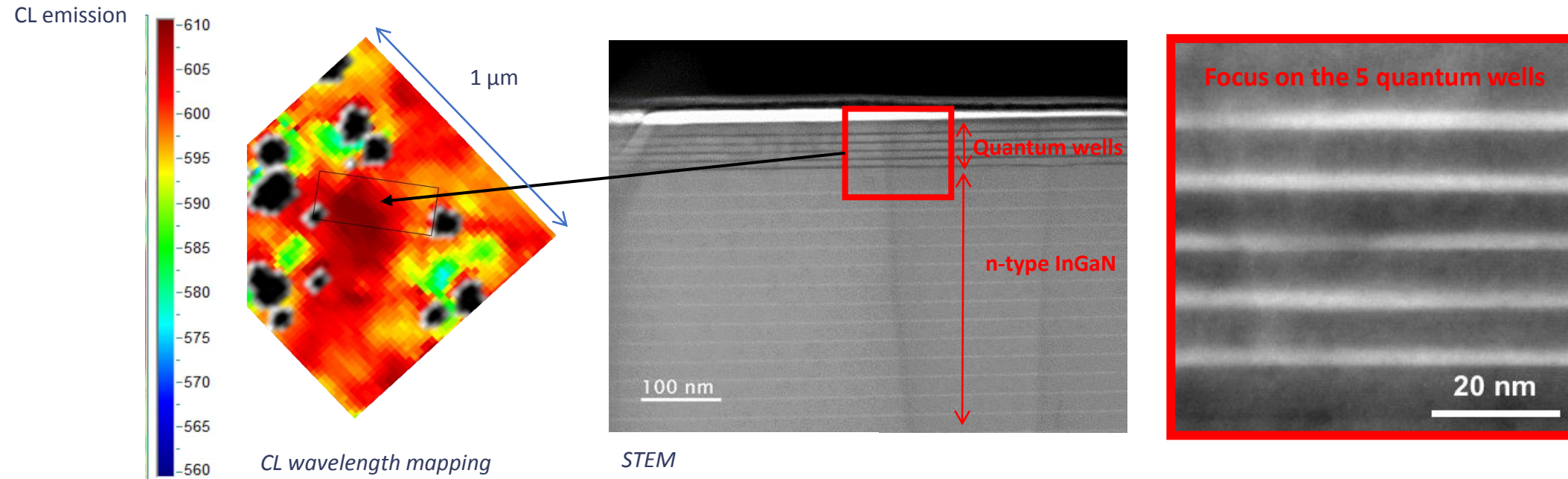
- Optimized growths conditions focused on red emission
- Central emission wavelength at 624 nm with FWHM = 58 nm at room Temperature



- 6,5% IQE is at the state of the art for InGaN based planar LEDs

# Up to 39% Indium in quantum Wells !

- Coupled characterizations between cathodoluminescence (CL) and scanning transmission electron microscopy (STEM)



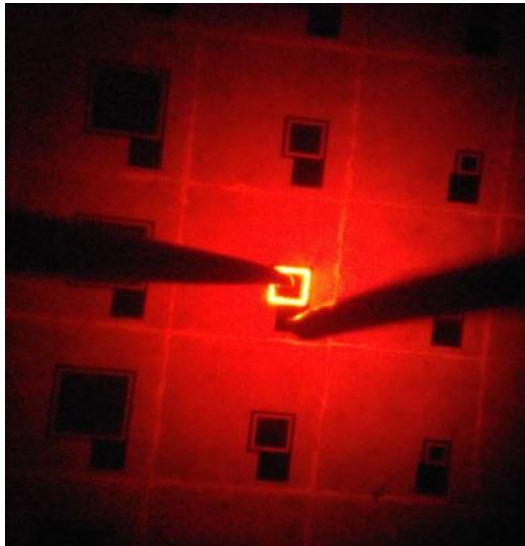
- Homogeneous Quantum Wells thickness of red emission
- 39% In content (determined by GPA analysis) vs 25% limit on std GaN substrate !
- demonstration that strain release is the good option to increase In content



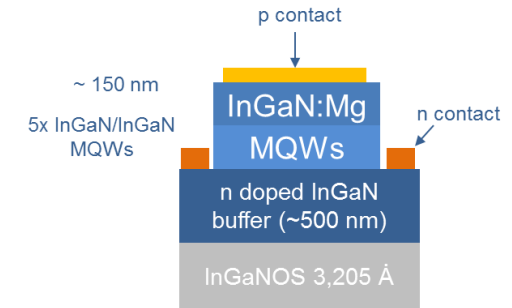
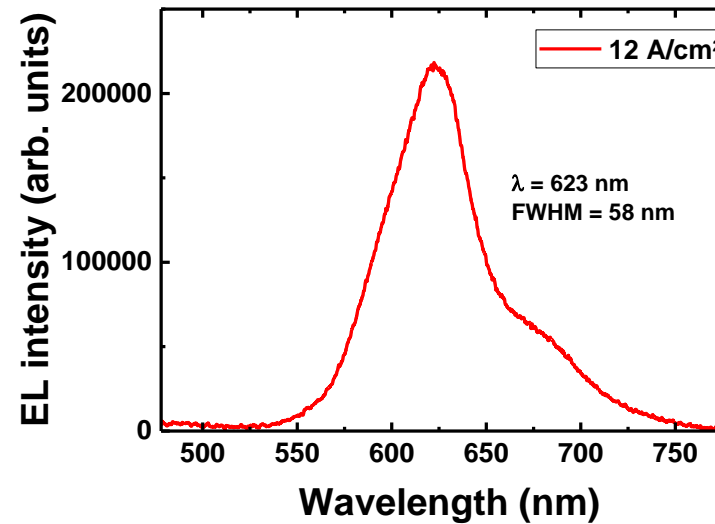
# First red micro-LED

- Emission @ 623 nm at 12 A/cm<sup>2</sup>

50x50 μm<sup>2</sup>



Picture from the front side  
Emission is from the back side



- Demonstration of first red full InGaN 50x50 μm<sup>2</sup>



## PART 3

# Conclusion & perspectives





- InGaNOS enables whole visible range emission with full InGaN structures
- InGaNOS enables In content up to 40% in QWs
- Full InGaN red micro-LED is demonstrated

- InGaNOS R&D line conversion in 150 mm
- 150 mm InGaNOS sampling to major LED and display makers
- Demonstration of 5% EQE red microLED

R&D work and First Industrialization Deployment (FID) related to the content presented here are supported by the French Government in the frame of the Important Project of Common European Interest (IPCEI) for microelectronics and as part of Nano 2022.

